

Electronic Patent Application Fee Transmittal

Application Number:	09648111			
Filing Date:	25-Aug-2000			
Title of Invention:	Method of patterning a metal layer in a semiconductor device			
First Named Inventor/Applicant Name:	Kwang-Jo Hwang			
Filer:	Esther Hyeri Chong/Hannah White			
Attorney Docket Number:	3430-0131P			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810